

UNITED STATES PATENT AND TRADEMARK OFFICE



APPLICATION NO.	FI	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	ATTORNEY DOCKET NO. CONFIRMATION NO		
09/713,215	1	1/16/2000	YASUNAGA KAYAMA	107314 2926			
25944	7590	11/27/2002					
OLIFF & E		E, PLC		EXAMINER			
P.O. BOX 19 ALEXAND		22320		KIM, PETER B			
				ART UNIT	PAPER NUMBER		
				2851			
				DATE MAILED: 11/27/2002			

Please find below and/or attached an Office communication concerning this application or proceeding.

;	Application No.	Applicant(s)	<u>IVV</u>
	09/713,215	KAYAMA, YASUNAG	Α
Office Action Summary	Examiner	Art Unit	
	Peter B. Kim	2851	
The MAILING DATE of this communication ap	ppears on the cover sheet wi	th the correspondence addre	ss
A SHORTENED STATUTORY PERIOD FOR REPI THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a rej - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statu. - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). Status	. 136(a). In no event, however, may a reply within the statutory minimum of thirtid will apply and will expire SIX (6) MON te, cause the application to become AB	eply be timely filed y (30) days will be considered timely. THS from the mailing date of this comm ANDONED (35 U.S.C. § 133).	unication.
1) Responsive to communication(s) filed on 11	October 2002 .		
	his action is non-final.		
3)☐ Since this application is in condition for allow			nerits is
closed in accordance with the practice unde Disposition of Claims	r <i>Ex parte Quayle</i> , 1935 C.[D. 11, 453 O.G. 213.	
4) Claim(s) 1-44 is/are pending in the application	on.		
4a) Of the above claim(s) is/are withdra	awn from consideration.		
5) Claim(s) is/are allowed.			
6)⊠ Claim(s) <u>1-44</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and/	or election requirement.		
Application Papers			
9)☐ The specification is objected to by the Examin			
10)☐ The drawing(s) filed on is/are: a)☐ acc	•		
Applicant may not request that any objection to t			
11) The proposed drawing correction filed on		sapproved by the Examiner.	
If approved, corrected drawings are required in r	• •		
12) The oath or declaration is objected to by the E	xammer.		
Priority under 35 U.S.C. §§ 119 and 120			
13) Acknowledgment is made of a claim for foreign	gn priority under 35 U.S.C. §	§ 119(a)-(d) or (f).	
a) ☐ All b) ☐ Some * c) ☒ None of:			
1. Certified copies of the priority documer			
2. Certified copies of the priority documer		·	
 3. Copies of the certified copies of the pricapplication from the International B * See the attached detailed Office action for a lis 	ureau (PCT Rule 17.2(a)).		ige
14) ☐ Acknowledgment is made of a claim for domes	•		plication).
a) The translation of the foreign language p	• •		
15) Acknowledgment is made of a claim for domes Attachment(s)	suc priority under 35 U.S.C.	99 120 and/or 121.	
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of I	Summary (PTO-413) Paper No(s). nformal Patent Application (PTO-15	

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DETAILED ACTION

Applicant's arguments filed on October 11, 2002 (paper #9) have been fully considered

Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

Claims 42-44 are rejected under 35 U.S.C. 112, first paragraph, as containing subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention. The written disclosure does not seem to disclose the transaction system that transacts a reaction force.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 1. Claims 1-8, 9-12, and 18-41 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akimoto et al. (Akimoto) (6,359,688) in view of Hayashi (6,036,162).

Akimoto discloses an exposure apparatus and a method of making an exposure apparatus and a method of exposing a pattern of a mask (7) onto a substrate or an object (W), with a projection system (PO), a holder (not shown) to hold the projection system, acceleration detector (16UY, 16Dy) located on the projection system to detect information concerning displacement of

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the projection system, an actuator (34), a driver connected to the actuator to drive the actuator in response to detection results of the detector (Fig. 2). Akimoto also discloses actuator including piezoelectric elements (col. 12, lines 13-16), a mask stage (8, 9) for holding and moving the mask, and a substrate stage or an object stage (12, 15) for moving and holding the substrate or the object. However, Akimoto does not disclose the actuator arranged on the holder for holding the projection system. Hayashi discloses in Figure 7, an exposure apparatus and method where the actuators (235) are located in the holder (224) and the acceleration detectors are located on the holder. Hayashi also discloses the mainframe (224) that mounts the projection system by means of the holder. Although, Akimoto and Hayashi does not disclose a distortion sensor, since both references discloses the acceleration sensor which detects oscillation, it would have been obvious to one of ordinary skill in the art to use distortion sensor. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to provide the actuators on the holder and the acceleration detectors on the holder in order to reduce deformation of the apparatus and effectively suppress the vibration with high degree of accuracy (col. 4, lines 52-64).

2. Claims 13-17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akimoto et al. (Akimoto) in view of Hayashi as applied to claims 1, 18 and 30 above, and further in view of Watson (5,959,427).

The further difference between modified Akimoto and the claimed invention is the exposure apparatus comprising a compensatory driving system that applied compensatory force to the stationary part of the object stage drive system. Watson discloses in Figure 3, an object stage drive system that includes movable part and stationary part and a compensatory driving

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system applies force to stationary part of the stage drive system and a compensatory driving system (60, 62) that applied force to the stationary part. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to provide a compensatory driving system to the invention of Akimoto in order to ensure that there is no uncanceled reaction moment and no disturbance of the base stability (the abstract of Watson).

Response to Arguments

Applicant argues that the cited references do not disclose an actuator arranged on the holder. However, Hayashi discloses in Fig. 7 and col. 19, lines 25-37, actuator anchored to the top plate of the first column 224, which is the holder connected to the projection system.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Peter Kim whose telephone number is (703) 305-0105. The examiner can normally be reached on Monday-Thursday from 6:30 AM to 4:00 PM. The examiner can also be reached on alternate Fridays during the same hours.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Russ Adams, can be reached on (703) 308-2847. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Group receptionist whose telephone number is (703) 308-0956.

Peter B. Kim
Patent Examiner

November 22, 2002

Aussell Adams

SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800